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APPLICANTS

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**** FOREIGN APPLICATIONS *******

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Verified and Acknowledged	<input type="checkbox"/>	JACK I BERMAN/ Examiner's Signature	<input type="checkbox"/>	Initials	JAPAN	5	10	4

ADDRESS

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TITLE

Projection electron microscope, electron microscope, specimen surface observing method and micro device producing method

FILING FEE RECEIVED 1460	FEES: Authority has been given in Paper No._____ to charge/credit DEPOSIT ACCOUNT No._____ for following:	<input type="checkbox"/> All Fees
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